



PATENT
Docket No. 20067/OPP031475US

IN THE UNITED STATES PATENT
AND TRADEMARK OFFICE

Applicant(s): Geon-Ook Park

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Serial No.: 10/748,652

) **February 26, 2004**

Filed: December 30, 2003

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Mark G. Hanley
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For: "Method of Forming a Trench in a
Semiconductor Device"

Group Art Unit: Unknown

Examiner: Unknown

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The patents and/or publications listed on the enclosed PTO Form-1449 are submitted pursuant to 37 CFR §§ 1.56, 1.97, and 1.98. Copies of the patents or publications are enclosed.

METHOD OF PAYMENT

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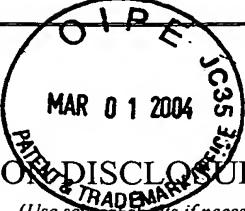
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February 26, 2004

Form PTO-1449 (Modified)	U.S. Department of Commerce Patent and Trademark Office		
 INFORMATION DISCLOSURE STATEMENT <i>(Use several sheets if necessary)</i>		Atty. Docket No.	Serial No.
		20067/OPP031475	10/748,652
		Applicant Geon-Ook Park	
Filing Date December 30, 2003	Group Art Unit Unknown		

U.S. PATENT DOCUMENTS							
*EXAMINER INITIALS		DOCUMENT NUMBER	ISSUE DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	A01	4,693,781	9/15/1987	Leung et al.			
	A02	5,915,195	6/22/1999	Fulford, Jr. et al.			
	A03	6,004,864	12/21/1999	Huang et al.			
	A04						
	A05						
	A06						
	A07						
	A08						
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	A19						
	A20						
	A21						
	A22						

EXAMINER	DATE CONSIDERED
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance <u>and</u> not considered. Include copy of this form with next communication to applicant.	